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### Controlling diffraction patterns with metagratings

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In this study we elaborate on the recent concept of metagratings proposed in Ra'di  $et\ al.$  [Phys. Rev. Lett. 119, 067404 (2017)] for efficient manipulation of reflected waves. Basically, a metagrating is a set of 1D arrays of polarization line currents which are engineered to cancel scattering in undesirable diffraction orders. We consider a general case of metagratings composed of N polarization electric line currents per supercell. This generalization is a necessary step to totally control diffraction patterns. We show that a metagrating having N equal to the number of plane waves scattered in the far-field can be used for controlling the diffraction pattern. To validate the developed theoretical approach, anomalous and multichannel reflections are demonstrated with 3D full-wave simulations in the microwave regime at 10 GHz. The results can be interesting for the metamaterials community as allow one to significantly decrease the number of used elements and simplify the design of wavefront manipulation devices, what is very convenient for optical and infra-red frequency ranges. Our findings also may serve as a way for development of efficient tunable antennas in the microwave domain.

For long time, the microwave community has approached a particular problem of anomalous reflection by means of reflectarray antennas [1, 2]. In such antennas, a linear phase variation is created along the surface, allowing one to reflect incident waves to a desirable angle. With the development of nanofabrication technologies and metasurfaces, the concept of reflectarrays was transposed to infra-red and optical frequency domains [3, 4]. A metasurface is represented by a 2D dense distribution of subwavelength scatterers and a reflectarray is a particular case of a metasurface which can generally be used for various applications other than anomalous reflections. However, reflectarrays suffer from low efficiencies for angles of anomalous reflection approximately greater than 45 degrees [5]. Extensive research in the area established a strong theoretical ground in the form of equivalence principle [6] for the design of wavefront manipulation devices based on the use of metasurfaces. As such, multichannel reflection with metasurfaces was demonstrated both theoretically and experimentally in [7]. Recently, a metasurface performing highly efficient anomalous reflection at steep angle has been demonstrated in [8] on the basis of the concept of metasurfaces possessing strong spatial dispersion [5, 9]. Unfortunately, a theoretical framework to design strongly spatial dispersive metasurfaces has not been developed yet, making the design of a sample time consuming [if it is possible at all] as it requires 3D fullwave simulations. In spite of advances in the field of

metasurfaces, drawbacks concerning design complexity and material losses still exist, rendering implementation of high performance devices very challenging in some frequency ranges [10].

In this study we elaborate on the recent concept of metagratings [11] for the manipulation of reflected waves. Basically, a metagrating is a set of 1D arrays of scatterers such as polarization line currents, separated by a distance of the order of the operating wavelength  $\lambda$ . Polarization line currents are used to cancel scattering in undesirable diffraction orders. Metagratings allow one to significantly decrease the number of constitutive scatterers in contrast to metasurfaces where scatterers are tightly packed in the plane. This reduction can be very attractive to reduce the fabrication complexity as well as the joule losses.

On the theoretical level, metasurface and metagrating are described differently. As a metasurface is composed of deeply subwavelength tightly packed elements, one can introduce averaged surface impedances. Meanwhile, a metagrating is treated as an array of polarization line currents separated by distances much larger than their sizes. Even though, there can be many polarization line currents in a supercell the separation between the currents remains on the order of operating wavelength and one would speculate by introducing average surface impedances.

It has been already shown that having just a single line current per period allows one to cancel specular reflection and perform perfect beam splitting and anomalous reflection [11–13]. In [14], the authors numerically and experimentally demonstrated the possibility to perform highly efficient broadband anomalous reflection with a Huygens' metasurface having just two meta-atoms per supercell

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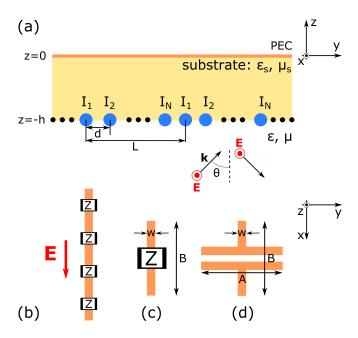


FIG. 1. (a) System under consideration: a periodic array of line currents  $\mathbf{J}_{nq} = I_q \exp[-jk\sin[\theta]nL]\delta(y-y_{nq},z+h)\mathbf{x}_0$  (blue circles) placed on PEC-backed dielectric substrate having permittivity  $\varepsilon_s$ , permeability  $\mu_s$  and thickness h. The array is excited by a plane wave incident at angle  $\theta$  and having TE polarization. (b) A line current implemented as a 1D array of loaded dipoles. (c) A PEC strip dipole of length B and width w loaded with lumped impedance Z. (d) A PEC strip dipole loaded with printed circuit capacitance having arms of length A.

necessary for cancelling specular reflection. Basically, the same functionality was demonstrated in [11, 13] where a single meta-atom per supercell and the substrate thickness were used as degrees of freedom instead of two meta-atoms per super cell. In this sense, the work in Ref. [14] is very similar to the ones on metagratings. Chalabi et al. also demonstrated the possibility to perform near-perfect anomalous reflection using two line currents per super cell [15] that are necessary for eliminating reflection in the zeroth and minus first diffraction orders. Recently, an implementation of a graphene-based tunable metagrating operating in the THz frequency range was suggested in [16].

In the present work, we study a general case of metagratings having N polarization line currents per super cell. This generalization is a necessary step for controlling diffraction patterns when the number of plane waves scattered in the far-field is greater than three. Although, the authors of Ref. [14] discussed the number of metaatoms per super cell necessary for controlling arbitrary number of plane waves diffracted in the far-field, a clear theory for designing a N-meta-atoms Huygens' metasurface was not elaborated.

Gaining control over many diffraction orders can be particularly interesting for implementing tunable devices and performing multichannel reflection. Indeed, having

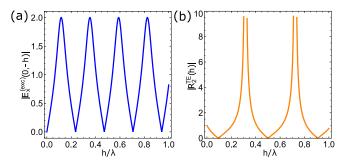


FIG. 2. (a) Dependence of the excitation field  $[\theta=0]$  acting on a metagrating on the thickness of the substrate h when  $\varepsilon_s=4.5$  and  $\mu_s=1$ . (b) Absolute values of the  $R_2^{TE}$  vs. the thickness of the substrate when  $\theta=0$ , r=l=1, N=3 and  $L=\lambda/\sin[60^o]$ . The rest of  $R_m^{TE}$  does not have poles under these parameters.  $\lambda$  is the operating vacuum wavelength.

many identical wires but being able to control polarization currents in each of them allows one to perform all possible transformations of the diffraction pattern with the same device, where the only restriction remains the device size. Moreover, metagratings can operate in a broad frequency range as usually does not require resonance response of meta-atoms. Broadband response of metagratings with a single and couple of polarization currents per supercell was demonstrated in [13] and [15], respectively.

As a physical system, we consider a 1D periodic array of polarization electric line currents placed over a grounded dielectric substrate of thickness h and excited by an incident harmonic TE-polarized plane wave at angle  $\theta$  where  $\exp[j\omega t]$  time dependence is assumed. The array has period L and consists of super cells each having N equally separated line currents by the distance d=L/N. The schematics of the considered system is presented in Fig. 1 (a). A line current is imagined as a tightly packed row of point dipoles orientated in the same direction, see Fig. 1 (b). Practically, one can realize the dipoles as the loaded rods considered in Fig. 1 (c) and (d).

In the presence of the grounded substrate the excitation field takes the following form

$$E_x^{exc}(y, z \le -h) = \left(e^{-j\beta_0 z} + R_0^{TE} e^{j\beta_0(z+2h)}\right) e^{-jk\sin[\theta]y}. \tag{1}$$

Electric line currents in the array are represented as current densities  $\mathbf{J}_{nq}(\mathbf{r}) = I_q \exp[-jk \sin[\theta]nL]\delta(y-y_{nq},z+h)\mathbf{x}_0$  where  $\delta(y,z)$  is the Dirac delta function,  $y_{nq}=nL+(q-1)d$ , n and q take integer values from  $-\infty$  to  $+\infty$  and from 1 to N, respectively. The term  $\exp[-jk\sin[\theta]nL]$  represents the phase variation of the currents introduced by the incident wave. Radiation of the array of electric line currents is represented by a series of Hankel functions [17, 18] of the second kind. It can be shown by means of the Poisson's formula [see Supplementary Material at [19]] that the electric field of the wave radiated

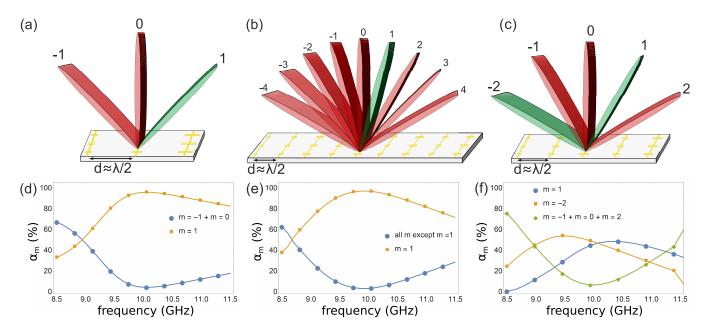


FIG. 3. The top row of figures demonstrates schematics of simulated metagratings with (a) N=3, (b) N=9 and (c) N=5, the green and white lobes depict excited and canceled diffraction orders respectively. Figures in the bottom row depict obtained from 3D full-wave simulations frequency responses of the metagratings corresponding to the figures in the top row. (a), (d) The example of anomalous reflection at angle of 50° with the metagrating having N=3,  $L=\lambda/\sin[50^\circ]$ , and loads  $[in \eta/\lambda, \tilde{\kappa}=26.80 \text{ mm}] Z_1=-14.5j, Z_2=-6.86j, Z_3=-4.43j.$  (b), (e) The example of small-angle anomalous reflection  $[of 12.5^\circ]$  with metasurface having N=9,  $L=4\lambda/\sin[60^\circ]$  and loads  $[in \eta/\lambda, \tilde{\kappa}=27.43 \text{ mm}] Z_1=-j7.62, Z_2=-j6.96, Z_3=-j6.19, Z_4=-j5.55, Z_5=-j5.18, Z_6=-j3.57, Z_7=-j3.02, Z_8=-j18.7, Z_9=-j10.1.$  (c), (f) The example when out of five only  $-2^{\text{nd}}$  and  $1^{\text{st}}$  diffraction orders are equally excited with the metagrating having N=5,  $L=2\lambda/\sin[50^\circ]$  and loads  $[in \eta/\lambda, \tilde{\kappa}=27.18 \text{ mm}] Z_1=-9.00j, Z_2=-5.88j, Z_3=-6.59j, Z_4=-3.03j, Z_5=-5.14j$ . The substrate is Arlon AD450  $[\varepsilon_s=4.5]$ , h=3 mm,  $B=\lambda/10=3 \text{ mm}$  and  $w=3\text{mil}\approx 76.2\mu\text{m}$ .

by the array outside the substrate can be written as

$$E_x(y, z < -h) = -\frac{k\eta}{2L} \sum_{m=-\infty}^{+\infty} \frac{\rho_m^{(I)} (1 + R_m^{TE})}{\beta_m} e^{-j\xi_m y + j\beta_m (z+h)}, \quad (2)$$

 $E_y=E_z=0$ . Corresponding magnetic fields can be found from the Maxwell equations. The series represent superpositions of plane waves having tangential component of wave vector equal to  $\xi_m=k\sin(\theta)+2\pi m/L$ , the longitudinal component is given by  $\beta_m=\sqrt{k^2-\xi_m^2}$  outside the substrate  $[k=\omega\sqrt{\varepsilon\mu}$  and  $k_s=\omega\sqrt{\varepsilon_s\mu_s}$  are respectively the wave numbers outside and inside the substrate]. Thus,  $R_m^{TE}$  is Fresnel's reflection coefficient from the grounded substrate of a plane wave having tangential component of the wave vector equal to  $\xi_m$ . Each current contributes to the amplitudes of the plane waves via the introduced quantity  $\rho_m^{(I)}$ 

$$\rho_m^{(I)} = \sum_{q=1}^{N} I_q \exp[j\xi_m(q-1)d]. \tag{3}$$

One can recognize in Eq. (3) a discrete Fourier transformation.

In general case when a plane wave illuminates a metagrating one can find r + l + 1 scattered plane waves in

the far-field, where r and l are largest integers satisfying the conditions  $\beta_r > 0$  and  $\beta_{-l} > 0$ . However, we can arbitrary control all of the r+l+1 plane waves if the number N of line currents in a super cell is equal to r+l+1. Indeed, amplitude  $A_m^{TE}$  of the  $m^{th}$  plane wave depends on  $\rho_m^{(I)}$  which is determined by the currents  $I_q$  [see Eq. (2)]

$$A_m^{TE} = -\frac{k\eta}{2L} \frac{\rho_m^{(I)} (1 + R_m^{TE}) e^{j\beta_m h}}{\beta_m} + \delta_{m0} R_0^{TE} e^{2j\beta_0 h}, \quad (4)$$

where  $\delta_{m0}$  is the Kronecker delta accounting for the incident wave reflected from the substrate. By setting all the amplitudes  $A_m^{TE}$   $(m \in [-l, r])$ , one can find necessary  $I_q$  from the corresponding  $\rho_m^{(I)}$  which are related via Eq. (3).

Thus, by designing currents  $I_q$  one can perform all possible transformations of the diffraction pattern, e.g. beam splitting, anomalous reflection, multichannel reflection, etc. When implementing line currents as thin perfectly conducting wires one can obtain necessary currents  $I_q$  by loading wires with suitable impedance densities  $Z_q$ . The last are found from

$$Z_q I_q = E_x^{(exc)}(y_{0q}, -h) - Z_{in} I_q - \sum_{p=1}^N Z_{qp}^{(m)} I_p$$
 (5)

where the right-hand side simply represents total elec-

tric field at the location of the qth wire in the zeroth supercell  $[y_{0q} = (q-1)d, z = -h]$ . Here, we also introduce notations for the input impedance density of wires  $Z_{in} = k\eta H_0^{(2)}[kr_0]/4$ , with  $H_0^{(2)}[kr_0]$  being the Hankel function of the second kind and  $r_0$  the radius of the wires, and for the mutual impedance densities  $Z_{qp}^{(m)}$  which account for interaction between the wires and between the wires and the grounded substrate. When a wire is realized as a perfectly conducting strip of width w, the radius is  $r_0 = w/4$  [18]. See Supplementary Material at [19] for the derivation of Eq. (5) and expressions of the mutual impedance densities.

Generally, currents found from (4) correspond to active and lossy loads  $Z_q$  calculated from (5). From a practical point of view, we are interested only in passive and lossless metagratings where  $\Re[Z_q] = 0$ , i.e. which cannot radiate energy by themselves and do not require engineered joule losses. A metagrating should redistribute the energy of the incident wave between r+l+1 diffracted in the far-field plane waves. Then, the power conservation condition when assuming a unity amplitude of the incident wave reads as

$$\sum_{m=-l}^{r} \alpha_m = 1, \quad \alpha_m = \left| A_m^{TE} \right|^2 \frac{\beta_m}{\beta_0}, \tag{6}$$

where  $\alpha_m$  is the part of the incident energy going in the  $m^{th}$  diffraction order.

In contrast to the case of metagratings having a single line current in a super cell [11–13], when it comes to greater number of line currents per supercell there are no exact analytical formulas for reactive load impedance densities necessary for obtaining some diffraction pattern. To approach this problem we develop a very simple real valued genetic algorithm [20] which allows one to find reactive  $Z_q$  with given impedance reactivity accuracy p for a desired diffraction pattern obtained with given transformation accuracy  $\alpha$ . The impedance reactivity accuracy is defined in accordance with the following inequality  $\sqrt{\sum_{q=1}^{N} |Re[Z_q]/Z_q|^2} < p$ . A diffraction pattern is set by assigning to all  $\alpha_m^0$  certain values. Phases  $\phi_m=\arg[A_m^{TE}]$  are assumed to be not important and assigned randomly. Transformation accuracy  $\alpha$  means that one is satisfied with a transformation when the part of the incident energy going in the  $m^{th}$  diffraction order is within the range  $\alpha_m = \alpha_m^0 \pm \alpha$ . Still, at each step the genetic algorithm deals with  $\alpha_m > 0$  constrained by the energy conservation condition (6).

When designing a metagrating, one should also take care of choosing parameters of the substrate. First of all, when substrate's thickness is varied the value of the excitation field Eq. (1) on a metagrating passes through zeros as illustrated in Fig. 2 (a). Clearly, a metagrating cannot be excited when the excitation field is zero on its plane. And secondly, the reflection coefficient  $R_m^{TE}$  as a function of h has poles when m is such that  $k < \xi_m$  but  $k_s > \xi_m$  [Fig. 2 (b)]. The poles correspond to excitation

of waveguide modes inside the substrate. Thus, assuming  $\varepsilon_s$  and  $\mu_s$  of the substrate are set, one should choose the thickness: (i) corresponding to vicinity of the maximum of the excitation field on a metagrating and (ii)  $|R_m^{TE}(h)| \neq \infty$ .

One can realize the line currents as dense 1D arrays of loaded dipoles [separated by distance  $B \ll \lambda$  and having lumped load equal to Z] as in Figs. 1 (b) and (c). Then, the load impedance density is simply  $\mathbb{Z}/\mathbb{B}$ . A capacitive load can be realized as a printed circuit capacitance as illustrated in Fig. 1 (d) for which  $Z = -j\eta\kappa/(A\varepsilon_{eff})$ [when other parameters B and w are fixed],  $\kappa$  is the proportionality factor,  $\varepsilon_{eff}$  is approximated as  $(1+\varepsilon_s)/2$  and  $\mu_s$  is assumed equal to 1. The proportionality factor  $\kappa$ was introduced in [12] for the case of a single line current per supercell. However, it turns out that in the general case of many line currents per supercell one can successfully use the same proportionality factor for all currents, i.e. independently on q. Thus, when load impedance densities  $Z_q$  are found from the genetic algorithm, one can easily calculate arms lengths of necessary printed capacitors as  $A_q = -\tilde{\kappa}/(\Im[Z_q]\frac{\lambda}{\eta}\varepsilon_{eff}), \ \tilde{\kappa} = \lambda\kappa/B.$ 

In order to validate the developed theoretical basis, we perform 3D full-wave simulations with COMSOL Multiphysics. We demonstrate three examples of metagratings designed to operate at 10 GHz [ $\lambda \approx 30$  mm] and perform different transformations of the diffraction pattern as shown in Fig. 3. A polarization line current is implemented as a 1D array of capacitively loaded perfectly conducting strips [as it schematically shown in the top row of Fig. 3]. In all the examples normally incident plane wave is assumed, i.e.  $\theta=0$ .

When performing a large-angle anomalous reflection with a metagrating, overall there are three diffraction orders and therefore only three polarization line currents per supercell are necessary to cancel the  $-1^{st}$  and  $0^{th}$ diffraction orders, as illustrated in Fig. 3 (a). Figure 3 (d) depicts the frequency response of the metagrating performing anomalous reflection at angle of  $50^{\circ}$ . The situation is more difficult in case of a small-angle anomalous reflection with the presence of many high diffraction orders and when the energy should be scattered only in the first one. Indeed, in the example of Fig. 3 (b) there are nine diffraction orders and the metagrating with nine polarization currents is used to cancel scattering in all of them except the first one corresponding to an anomalously reflected wave at angle of 12.5°. Figure 3 (e) demonstrates the frequency dependence of the metagrating's performance efficiency. Clearly, metagratings are not restricted to anomalous reflection application and can be used for multichannel reflection. One can distribute the energy of an incident wave between all diffraction orders in a desirable manner. For instance, Figs. 3 (c) and (f) demonstrate the scenario when the metagrating having five polarization currents is used to split normally incident waves between the  $-2^{\rm nd}$  and  $1^{\rm st}$ diffraction orders and cancel scattering in the other three diffraction orders.

In conclusion, it has been shown that a metagrating having the number of polarization line currents per super cell equal to the number of plane waves scattered in the far-field can be used for controlling the diffraction pattern. Namely, equations (3) and (4) allowing one to find currents realizing desirable transformations have been derived. Since there are no analytical formulas of reactive load impedance densities (5) for direct design, genetic algorithms have been implemented for that purpose. The diffraction orders control has been demonstrated by means of 3D full-wave simulations on the ex-

amples of anomalous reflection and equal redistribution of the energy of the incident wave between two diffraction orders

The validation results can be very interesting for the metamaterials community to perform highly efficient control of light scattering. It allows one to significantly decrease the number of used elements and simplify the design, which is very convenient for optical and infra-red frequency ranges. Our findings also may serve as a way for development of efficient tunable antennas in the microwave domain.

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# Supplementary Material: Controlling Diffraction Patterns With Metagratings

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### Appendix A: Details on the formula (2)

A single line current  $\mathbf{J}(\mathbf{r}) = I\delta(y, z)\mathbf{x}_0$  radiates as [1]

$$E_x(y,z) = -\frac{k\eta}{4}IH_0^{(2)}[k\sqrt{y^2+z^2}], \quad E_y = E_z = 0,$$
 (A1)

where  $k = \omega \sqrt{\varepsilon \mu}$  and  $\eta = \sqrt{\mu/\varepsilon}$ ,  $H_0^{(2)}[k\sqrt{y^2 + z^2}]$  is the second kind Hankel function. Corresponding magnetic field is found from the Maxwell equations

$$H_y(y,z) = \frac{j}{k\eta} \frac{\partial E_x(y,z)}{\partial z}, \quad H_z(y,z) = -\frac{j}{k\eta} \frac{\partial E_x(y,z)}{\partial y}.$$
 (A2)

Consequently, radiation field of a periodic array of N electric line currents per super cell  $\mathbf{J}_{nq}(\mathbf{r}) = I_q \exp[-jk \sin[\theta] nL] \delta(y-y_{nq},z) \mathbf{x}_0$  [where  $y_{nq} = nL + (q-1)d$ , n and q take integer values from  $-\infty$  to  $+\infty$  and from 1 to N respectively] is given by a series of Hankel functions

$$E_x(y,z) = -\frac{k\eta}{4} \sum_{q=1}^{N} \sum_{n=-\infty}^{\infty} I_q e^{-jk \sin[\theta]nL}$$

$$H_0^{(2)} \left[k\sqrt{(y-nL-(q-1)d)^2 + z^2}\right]$$
(A3)

that can be calculated by means of the Poisson's formula stating that for a given "good" function f(w) the following identity takes place

$$\sum_{n=-\infty}^{+\infty} f(nL) = \sum_{m=-\infty}^{+\infty} \int_{-\infty}^{+\infty} \frac{dw}{L} f(w) e^{-j\frac{2\pi m}{L}w}.$$
 (A4)

Thus,

$$E_x(y,z) = -\frac{k\eta}{2L} \sum_{q=1}^N \sum_{m=-\infty}^\infty \frac{I_q}{\beta_m} e^{j\xi_m(q-1)d} e^{-j\xi_m y} e^{-j\beta_m|z|},$$

$$\xi_m = k \sin[\theta] + 2\pi m/L, \quad \beta_m = \sqrt{k^2 - \xi_m^2},$$
 (A5)

$$\int_{-\infty}^{+\infty} dw H_0^{(2)} [k\sqrt{(y-w)^2 + z^2}] e^{-j\xi_m w} = 2 \frac{e^{-j\xi_m y - j\beta_m |z|}}{\beta_m}.$$
(A6)

The effect of the grounded substrate on the field radiated by the array  $\mathbf{J}_{nq}(\mathbf{r}) = I_q \exp[-jk\sin[\theta]nL]\delta(y-y_{nq},z+h)\mathbf{x}_0$  can be derived in the same manner as in [2]. After some algebra one would arrive at the following expressions for the electric field profile inside (0 > z > -h) and outside (z < -h) the substrate

$$\begin{split} E_{x}(y,0 > z > -h) &= \\ \frac{k_{s}\eta_{s}}{2L} \sum_{m=-\infty}^{+\infty} \frac{\rho_{m}T_{m}^{TE}}{\gamma_{m}^{TE}\beta_{m}^{s}} \frac{\sin[\beta_{m}^{s}z]}{\sin[\beta_{m}^{s}h]} e^{-j\xi_{m}y}, \\ E_{x}(y,z < -h) &= \\ -\frac{k\eta}{2L} \sum_{m=-\infty}^{+\infty} \frac{\rho_{m}^{(I)}(1 + R_{m}^{TE})}{\beta_{m}} e^{-j\xi_{m}y + j\beta_{m}(z+h)}, \end{split}$$
 (A7)

 $E_y=E_z=0$ . Corresponding magnetic fields can be found from the Maxwell equations (A2). The series represent superpositions of plane waves having tangential component of wave vector equal to  $\xi_m=k\sin(\theta)+2\pi m/L$ , the longitudinal component is given by  $\beta_m=\sqrt{k^2-\xi_m^2}$  outside and by  $\beta_m^s=\sqrt{k_s^2-\xi_m^2}$  inside the substrate  $[k=\omega\sqrt{\varepsilon\mu}$  and  $k_s=\omega\sqrt{\varepsilon_s\mu_s}$  are respectively the wave numbers outside and inside the substrate]. Thus,  $R_m^{TE}$  and  $T_m^{TE}$  are the Fresnel's reflection and transmission coefficients respectively

$$R_m^{TE} = \frac{j\gamma_m^{TE} \tan[\beta_m^s h] - 1}{j\gamma_m^{TE} \tan[\beta_m^s h] + 1}, \quad T_m^{TE} = \frac{2j\gamma_m^{TE} \tan[\beta_m^s h]}{j\gamma_m^{TE} \tan[\beta_m^s h] + 1},$$

$$\gamma_m^{TE} = \frac{k_s \eta_s \beta_m}{k \eta \beta_m^s}, \tag{A8}$$
where  $\eta = \sqrt{\mu/\varepsilon}$  and  $\eta_s = \sqrt{\mu_s/\varepsilon_s}$ .

#### Appendix B: Calculation of load-impedance densities

Necessary currents  $I_q$  can be achieved by engineering the load-impedance densities  $Z_q$  defined as  $I_q Z_q =$ 

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 $E_x^{(loc)}(y_{0q},-h)$ , where  $E_x^{(loc)}(y_{0q},-h)$  is the total electric field at the location of the  $q^{\rm th}$  line current  $[y_{0q}=(q-1)d,z=-h]$ . The self-action of the  $q^{\rm th}$  current in the zeroth supercell is given by  $-k\eta I_q H_0^{(2)}[kr_0]/4$   $[r_0$  is the effective radius of the line current which depends on its concrete practical realization]. For instance, when a line current is imitated as a perfectly conducting strip of width w the radius  $r_0=w/4$  [3]. The electric field created by  $q^{\rm th}$  line current from all supercells [but the zeroth one] reads

$$-\frac{k\eta}{2}I_q\sum_{n=1}^{\infty}\cos[k\sin[\theta]nL]H_0^{(2)}[k|nL|].$$

The electric field created by all other line currents is given by

$$-\frac{k\eta}{4} \sum_{p=1, p \neq q}^{N} \sum_{n=-\infty}^{\infty} I_p e^{-jk \sin[\theta]nL} H_0^{(2)}[k|(q-p)d - nL|].$$

Finally, the influence of the grounded substrate is accounted with

$$-\frac{k\eta}{2L} \sum_{p=1}^{N} \sum_{m=-\infty}^{+\infty} I_p e^{j\xi_m(p-q)d} \frac{R_m^{TE}}{\beta_m}.$$

Summarizing three previous equations and keeping in mind the excitation field the load-impedance densities  $Z_q$  can be calculated by the following formula

$$Z_{q} = \frac{1}{I_{q}} \left[ E_{x}^{(exc)}(y_{0q}, -h) - \frac{k\eta}{4} \sum_{p=1, p \neq q}^{N} \sum_{n=-\infty}^{\infty} I_{p} e^{-jk \sin[\theta]nL} \right] \times H_{0}^{(2)}[k|(q-p)d - nL|] - \frac{k\eta}{2L} \sum_{p=1}^{N} \sum_{m=-\infty}^{+\infty} I_{p} e^{j\xi_{m}(p-q)d} \frac{R_{m}^{TE}}{\beta_{m}} \right]$$

$$-\frac{k\eta}{2}\sum_{n=1}^{\infty}\cos[k\sin[\theta]nL]H_0^{(2)}[k|nL|] - \frac{k\eta}{4}H_0^{(2)}[kr_0].$$
 (B1)

The cumbersome equation (B2) can be rewritten in the compact form by introducing mutual impedance densities

$$Z_q I_q = E_x^{(exc)}(y_{0q}, -h) - Z_{in} I_q - \sum_{p=1}^N Z_{qp}^{(m)} I_p,$$
 (B2)

where  $Z_{in} = k\eta H_0^{(2)}[kr_0]/4$  is the input impedance density of wires and the mutual impedance densities  $Z_{qp}^{(m)}$  which account for interaction between the wires and between the wires and the grounded substrate are expressed as

$$Z_{qp}^{(m)} = \frac{k\eta}{4} \sum_{n=-\infty}^{\infty} H_0^{(2)}[k|(q-p)d - nL|]e^{-jk\sin[\theta]nL} + \frac{k\eta}{2L} \sum_{m=-\infty}^{+\infty} e^{j\xi_m(p-q)d} \frac{R_m^{TE}}{\beta_m}, \quad q \neq p,$$

$$Z_{qq}^{(m)} = \frac{k\eta}{2} \sum_{n=1}^{\infty} \cos[k\sin[\theta]nL]H_0^{(2)}[knL] + \frac{k\eta}{2L} \sum_{m=-\infty}^{+\infty} \frac{R_m^{TE}}{\beta_m}.$$
(B3)

<sup>[1]</sup> Leopold B Felsen and Nathan Marcuvitz, Radiation and scattering of waves (IEEE Press, New York, 1994).

<sup>[2]</sup> O. Rabinovich and A. Epstein, "Analytical design of printed-circuit-board (pcb) metagratings for perfect

anomalous reflection," IEEE Transactions on Antennas and Propagation , 1–1 (2018).

<sup>[3]</sup> Sergei Tretyakov, Analytical modeling in applied electromagnetics (Artech House, Norwood, MA, 2003).